



FORM PTO-1449 (Based on Form PTO-1449)

**PATENT AND TRADEMARK OFFICE**  
**INFORMATION DISCLOSURE CITATION**  
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Sheet 1 of 2

ATTORNEY DOCKET NO.

SERIAL NO.

9319S-000665

10/774,347

APPLICANT

SAWAMOTO et al.

FILING DATE

GROUP

02/06/2004

2822

**U.S. PATENT DOCUMENTS**

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.	IMS	6,023,097	02/08/2000	Chiang et al.	257/700	
2.		6,025,650	02/15/2000	Tsuji et al.	257/286	
3.		6,034,425	03/07/2000	Chiang et al.	257/697	
4.		6,288,445	09/22/2001	Kimura	257/737	
5.		2002/0017709	02/14/2002	Yanagisawa et al.	257/686	
6.		6,489,678	12/03/2002	Joshi	257/723	
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13.	IMS	6,903,458	06/07/2005	Nathan	257/737	

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Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No
1.	IMS	JP 10-340928	12/22/1998	JAPAN		Abstract

Examiner:

*John M. Seward*

Date Considered:

3-17-06

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	9319S-000665	10/774,347
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	Toshihiro SAWAMOTO	
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	02/06/2004	2822

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
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Examiner: <i>Adi M. Seward</i>	Date Considered: <i>3-17-06</i>
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